

## PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT										
NATURE OF CONVEYANCE:	ASSIGNMENT										
CONVEYING PARTY DATA											
<table border="1"> <thead> <tr> <th>Name</th> <th>Execution Date</th> </tr> </thead> <tbody> <tr> <td>Giovanni DE MICHELI</td> <td>06/10/2013</td> </tr> <tr> <td>Yusuf LEBLEBICI</td> <td>05/29/2013</td> </tr> <tr> <td>Michele DE MARCHI</td> <td>05/27/2013</td> </tr> <tr> <td>Davide SACCHETTO</td> <td>05/27/2013</td> </tr> </tbody> </table>		Name	Execution Date	Giovanni DE MICHELI	06/10/2013	Yusuf LEBLEBICI	05/29/2013	Michele DE MARCHI	05/27/2013	Davide SACCHETTO	05/27/2013
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Yusuf LEBLEBICI	05/29/2013										
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Davide SACCHETTO	05/27/2013										
RECEIVING PARTY DATA											
Name:	ECOLE POLYTECHNIQUE FEDERALE DE LAUSANNE (EPFL)										
Street Address:	EPFL-TTO										
Internal Address:	Quartier de l'innovation - J										
City:	Lausanne										
State/Country:	SWITZERLAND										
Postal Code:	1015										
PROPERTY NUMBERS Total: 1											
<table border="1"> <thead> <tr> <th>Property Type</th> <th>Number</th> </tr> </thead> <tbody> <tr> <td>Application Number:</td> <td>13899666</td> </tr> </tbody> </table>		Property Type	Number	Application Number:	13899666						
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Application Number:	13899666										
CORRESPONDENCE DATA											
<p>Fax Number:  <i>Correspondence will be sent via US Mail when the fax attempt is unsuccessful.</i></p> <p>Phone: 2026819860        Email: us-assg@felberip.com        Correspondent Name: Joseph L. Felber        Address Line 1: 14 HaMlacha St., Box 3026        Address Line 4: Ra'anana, ISRAEL 43661</p>											
ATTORNEY DOCKET NUMBER:	130058										
NAME OF SUBMITTER:	Joseph L. Felber										
Signature:	/Joseph L. Felber, Reg. No. 48,109/										

OP \$40.00 13899666

Date:

06/12/2013

**Total Attachments: 4**

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source=130058\_Assignment\_LEBLEBICI#page1.tif

source=130058\_Assignment\_SACCHETTO#page1.tif

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Attorney Docket No.: 130058

**Assignment of U.S. Patent Application**

FOR GOOD AND VALUABLE CONSIDERATION, the adequacy and receipt of which is hereby acknowledged by the undersigned inventor (hereinafter the "ASSIGNOR"), from:

**ECOLE POLYTECHNIQUE FEDERALE DE LAUSANNE (EPFL)**

having as its address:

**EPFL-TTO  
Quartier de l'innovation - J  
1015 Lausanne – Switzerland**

(hereinafter the "ASSIGNEE"), the undersigned ASSIGNOR hereby sells, assigns and transfers to ASSIGNEE the entire and exclusive right, title, and interest to U.S. Patent Application No. **13/899,666** entitled:

**AMBIPOLAR SILICON NANOWIRE FIELD EFFECT TRANSISTOR**

and filed on **May 22, 2013**, and any additional Letters Patent of the United States and applications therefor that may be obtained therefore on said patent or any continuation, divisional, substitute, reissue, or reexamination, opposition, or other post-grant proceeding thereof for the full term or terms for which the same may be granted.

The ASSIGNOR agrees to execute all papers necessary in connection with the application and any continuation, divisional, reissue, or reexamination, opposition, or other post-grant proceeding applications thereof and also to execute separate assignments in connection with such applications as the ASSIGNEE may deem necessary or expedient.

The ASSIGNOR further agrees to execute all papers necessary in connection with any interference, litigation, or other legal proceeding which may be declared concerning this patent or any continuation, divisional, reissue, or reexamination, opposition, or other post-grant proceeding thereof or additional Letters Patent or reissue patent issued thereon and to cooperate with the ASSIGNEE in every way possible in obtaining and producing evidence and proceeding with such interference, litigation, or other legal proceeding.

IN WITNESS WHEREOF, the undersigned inventor have affixed his signature.

Michele De Marchi  
(Signature)

Michele DE MARCHI  
(Type Name)

MAY 27, 2013  
(Date)

NO LEGALIZATION REQUIRED

**PATENT  
REEL: 030597 FRAME: 0035**

**Joseph L. Felber**, Adv. and Patent Attorney

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IN WITNESS WHEREOF, the undersigned inventor have affixed his signature.

  
\_\_\_\_\_  
(Signature)

Giovanni DE MICHELI  
(Type Name)

JUNE 10, 2013  
(Date)

NO LEGALIZATION REQUIRED

**PATENT  
REEL: 030597 FRAME: 0036**

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(Signature)

Yusuf LEBLEBICI  
(Type Name)

29/05/2013  
(Date)

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**PATENT  
REEL: 030597 FRAME: 0037**

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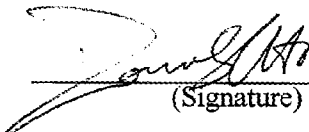
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\_\_\_\_\_  
(Signature)

**Davide SACCHETTO**  
\_\_\_\_\_  
(Type Name)

**27/05/2013**  
\_\_\_\_\_  
(Date)

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